

#3 1/2./02

Our Ref. No.: 051876P232

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Won-Ick Jang

Serial No. 09/753,065

Filed: December 29, 2000

For:

STICTION-FREE

MICROSTRUCTURE RELEASING METHOD FOR FABRICATING

MEMS DEVICE

Examiner: Lan Vinh

Art Group: 1765

RECEIVEL NOV 2 1 2002 TC 1700

BOX NON-FEE AMENDMENTS Commissioner for Patents Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

Dear Commissioner:

In connection with the Office Action mailed August 12, 2002, regarding the above-referenced application, Applicants respectfully request consideration of the following amendments and remarks below.